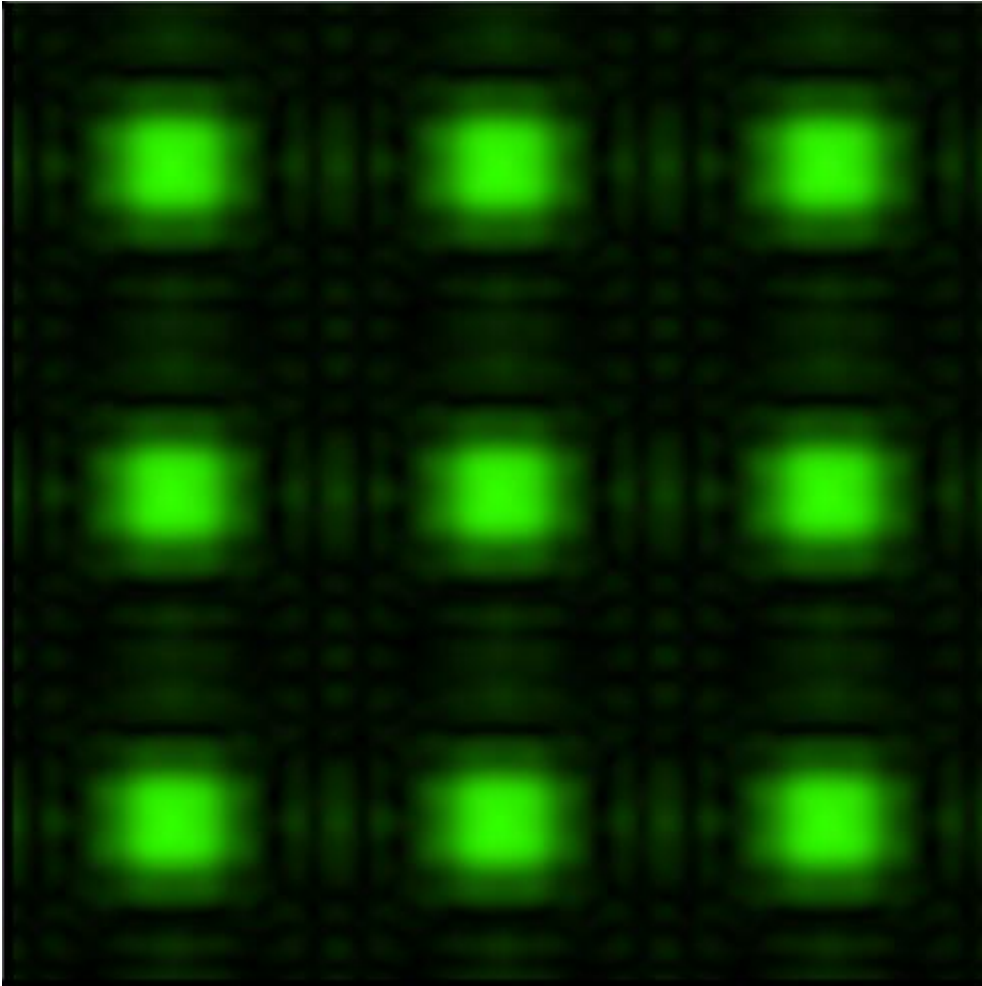


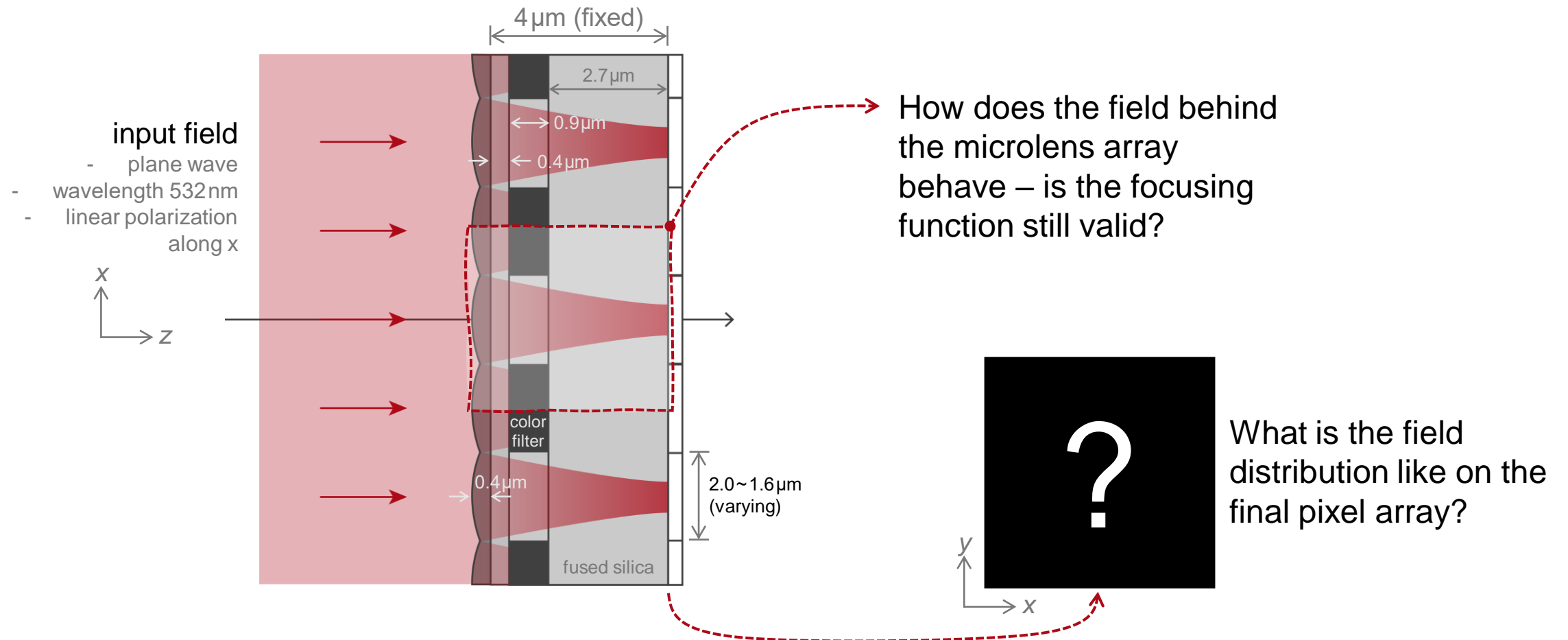
Analysis of CMOS Sensors with Microlens Array

Abstract



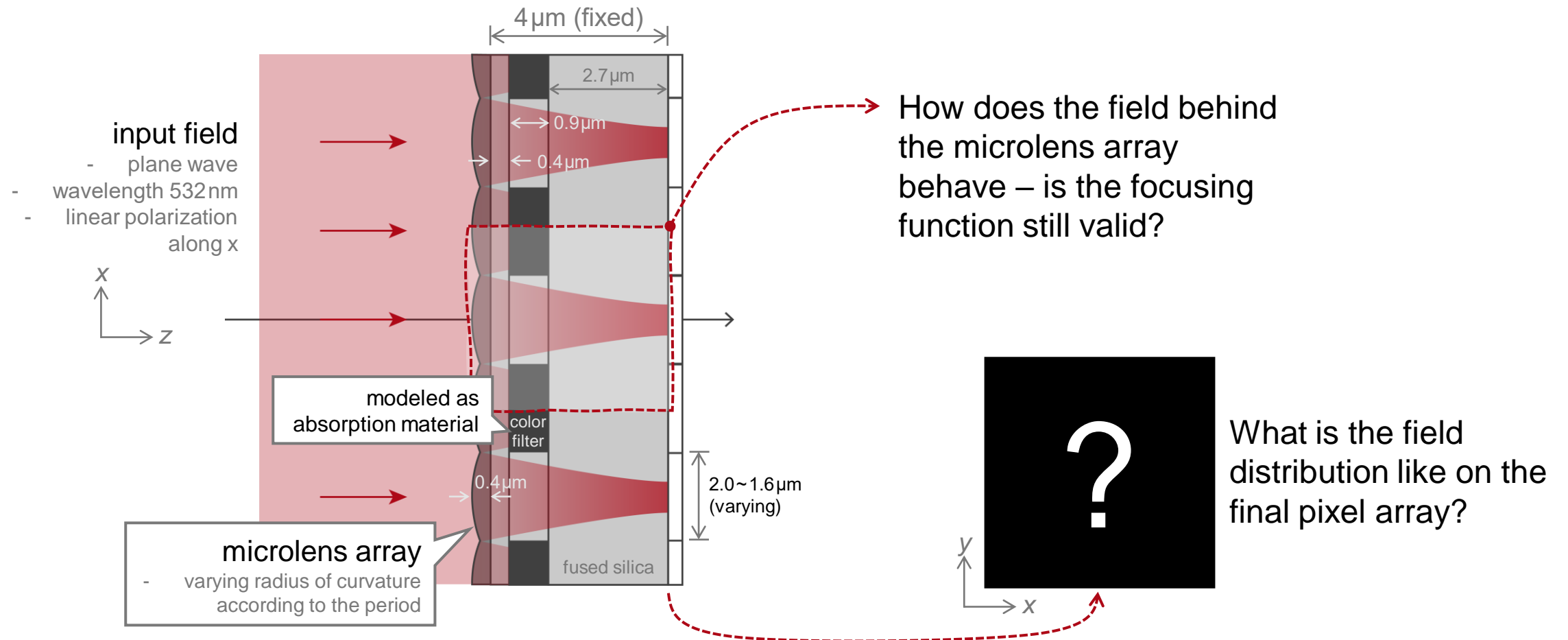
In the recent decades, the pixel size of CMOS sensors has scaled from more than $10\mu\text{m}$ to $2\mu\text{m}$ or even smaller. By decreasing the pixel size, higher spatial resolution has been achieved. At the same time, it brings questions to the functionality of the microlenses sitting on top of each pixel. In this example, we investigate the performance of CMOS sensor with pixel size equal to or below $2\mu\text{m}$. The rigorous FMM / RCWA is employed for the simulation to check the effectiveness of the microlenses.

Modeling Task



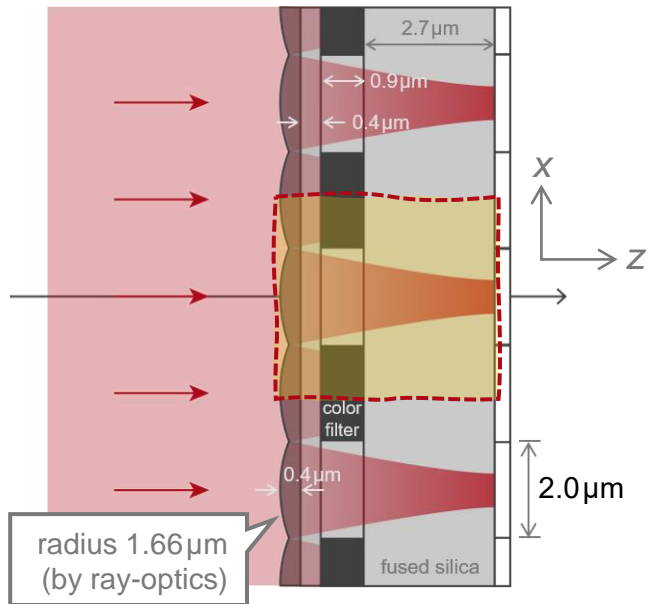
geometry parameters adapted from Y. Huo, *et al.*, Opt. Express 18, 5861-5872 (2010)

Modeling Task

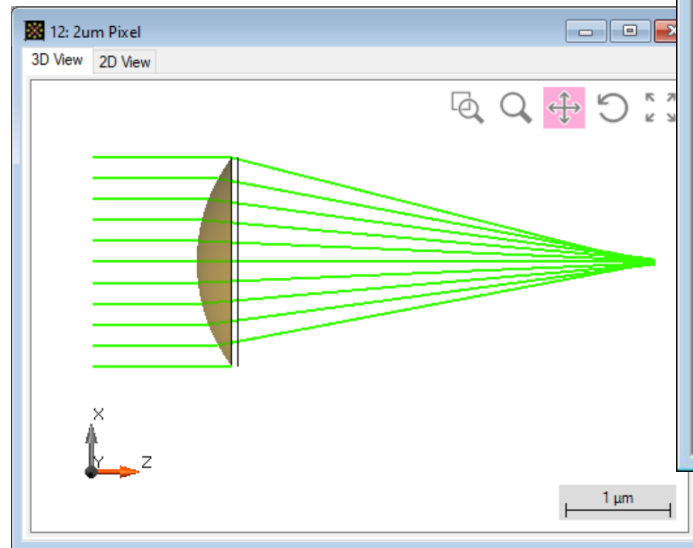


geometry parameters adapted from Y. Huo, *et al.*, Opt. Express 18, 5861-5872 (2010)

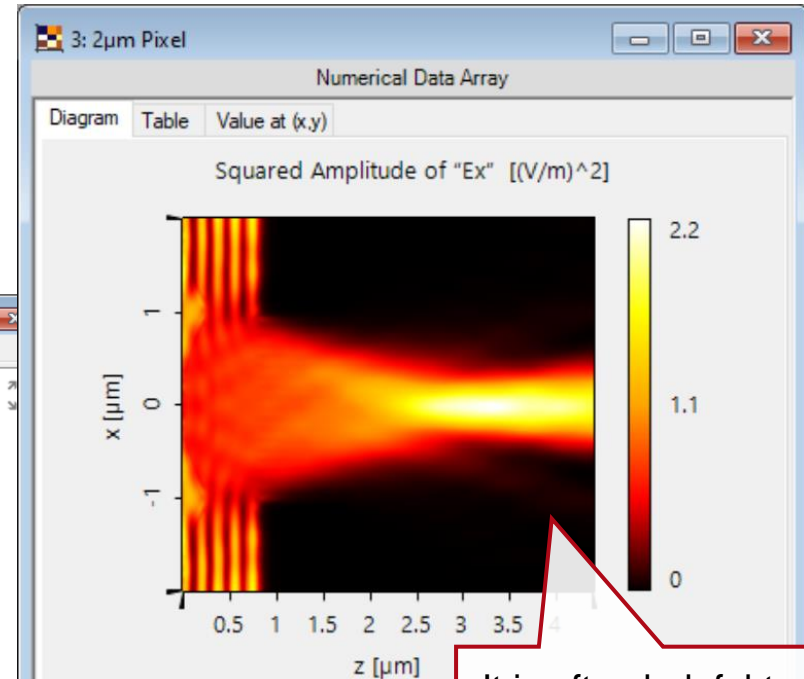
Microlens for 2 μm Pixel (x-z Simulation)



ray-optics design

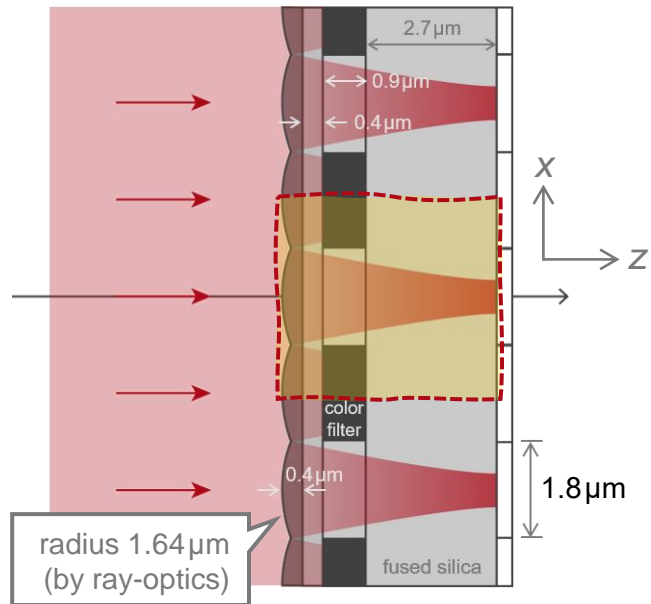


FMM / RCWA simulation (x-z)

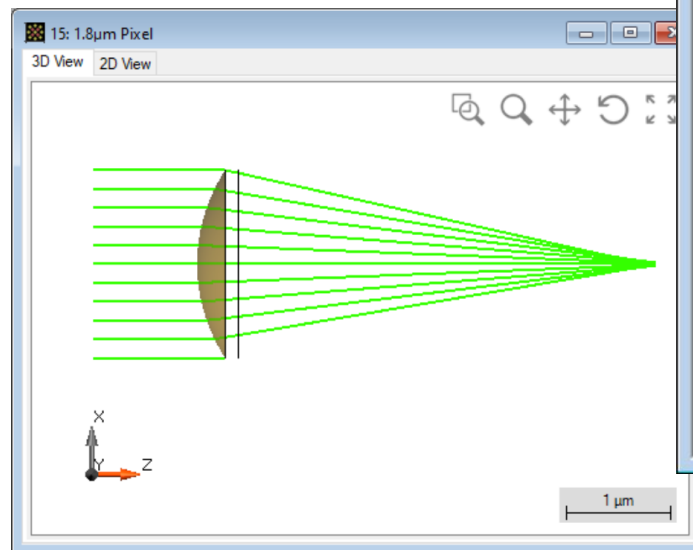


It is often helpful to make a 2D (x-z) simulation first so to get a fast understanding of the situation.

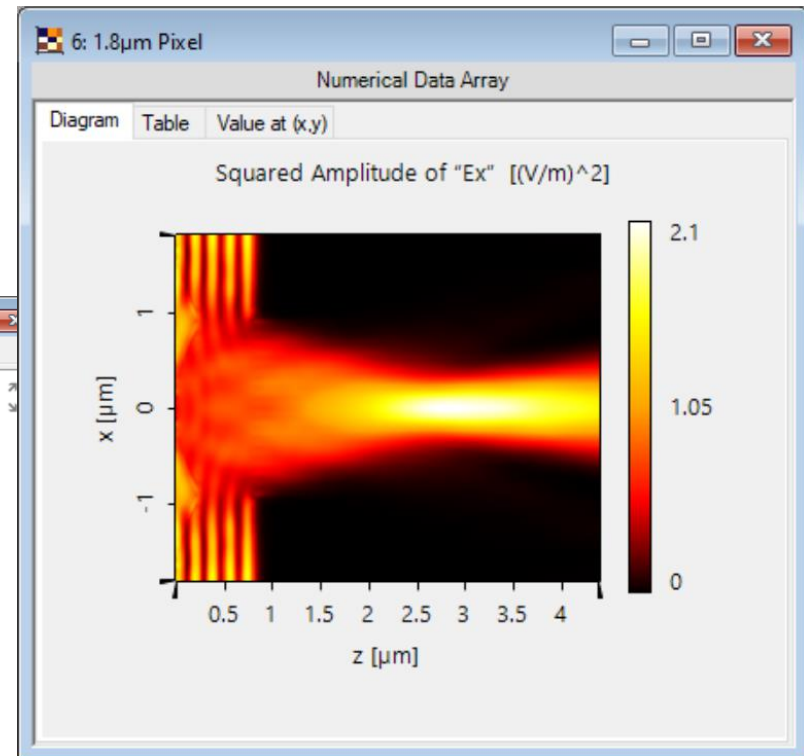
Microlens for 1.8 μm Pixel (x-z Simulation)



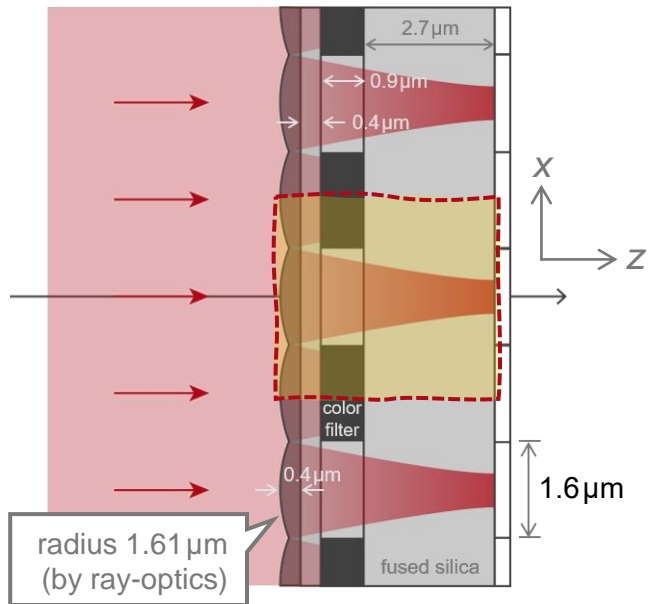
ray-optics design



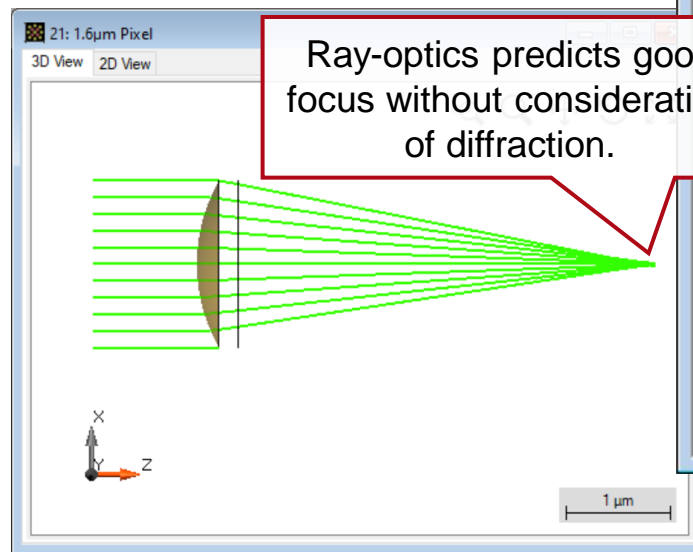
FMM / RCWA simulation (x-z)



Microlens for 1.6 μm Pixel (x-z Simulation)

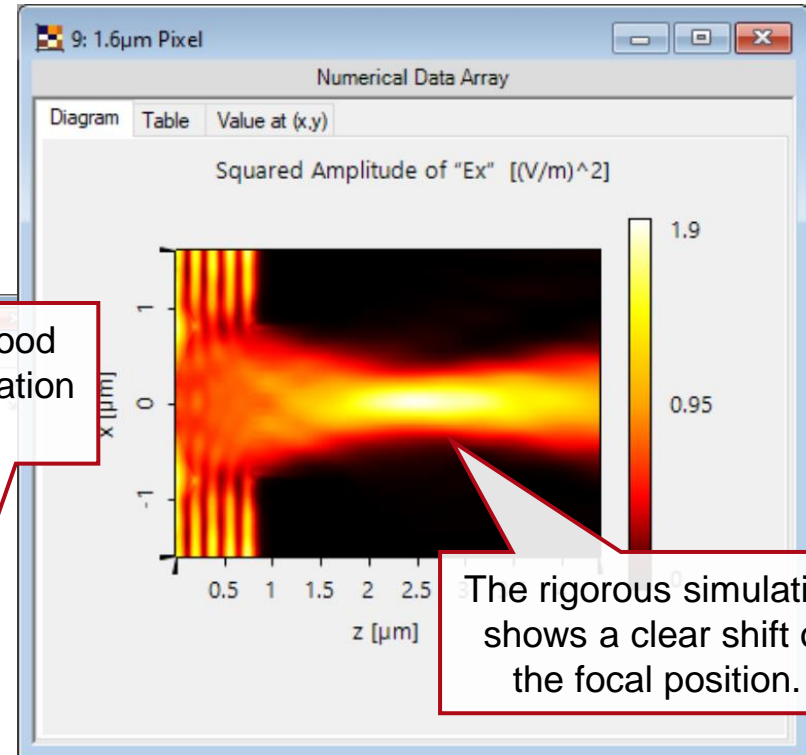


ray-optics design



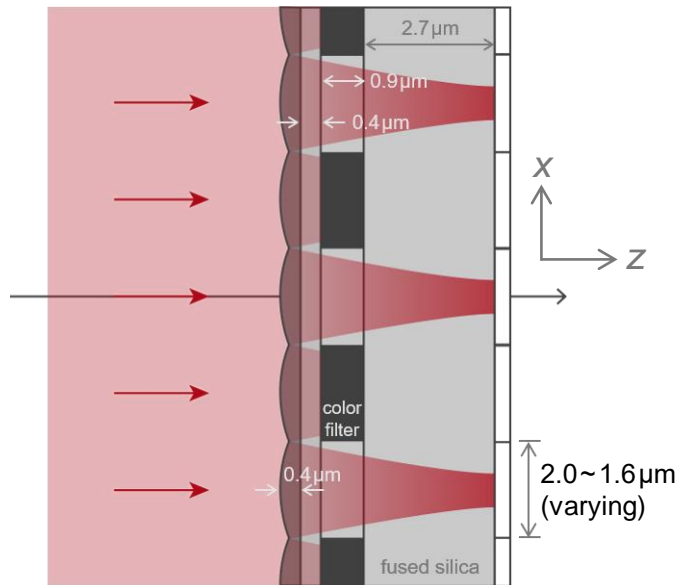
Ray-optics predicts good focus without consideration of diffraction.

FMM / RCWA simulation (x-z)

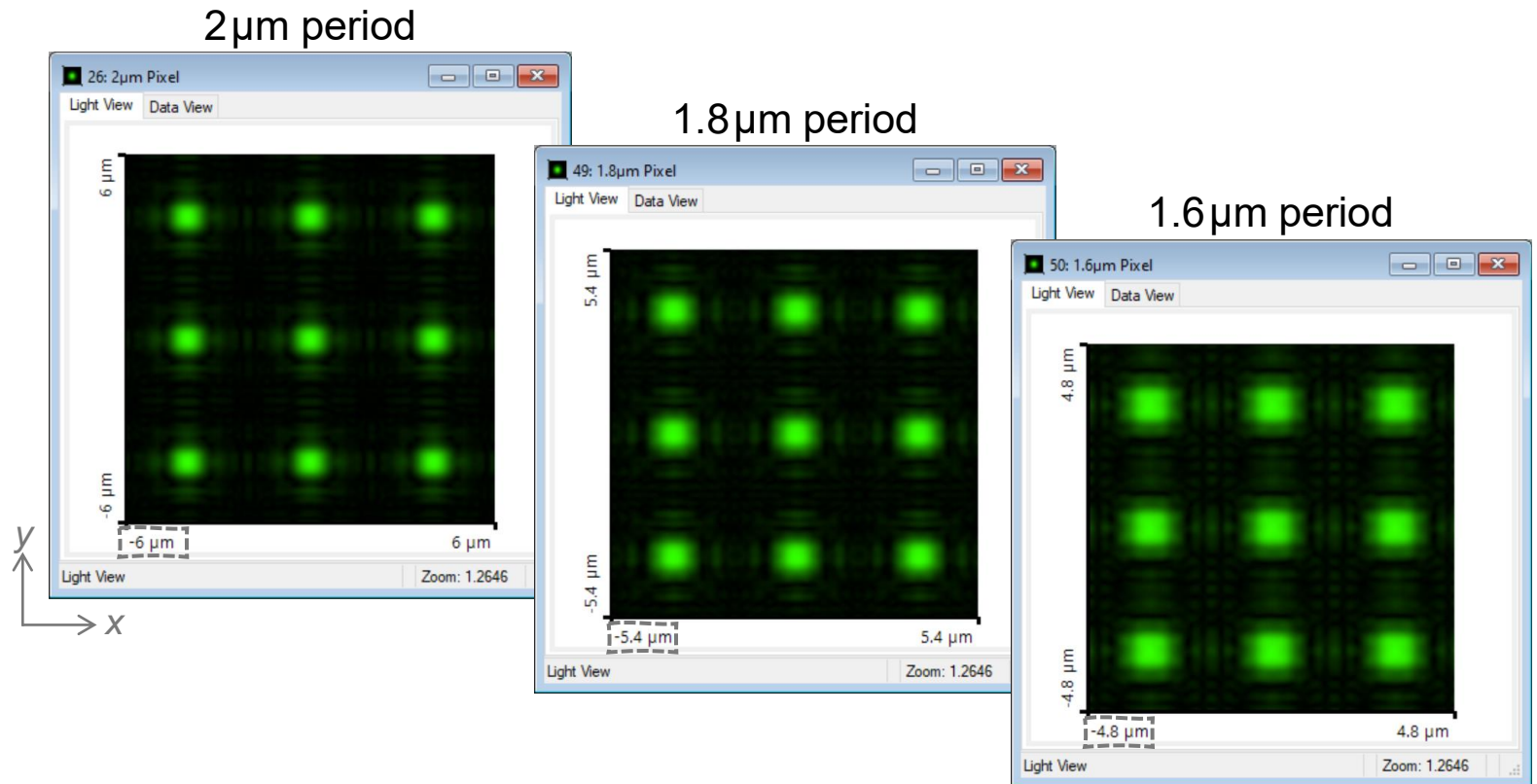


The rigorous simulation shows a clear shift of the focal position.

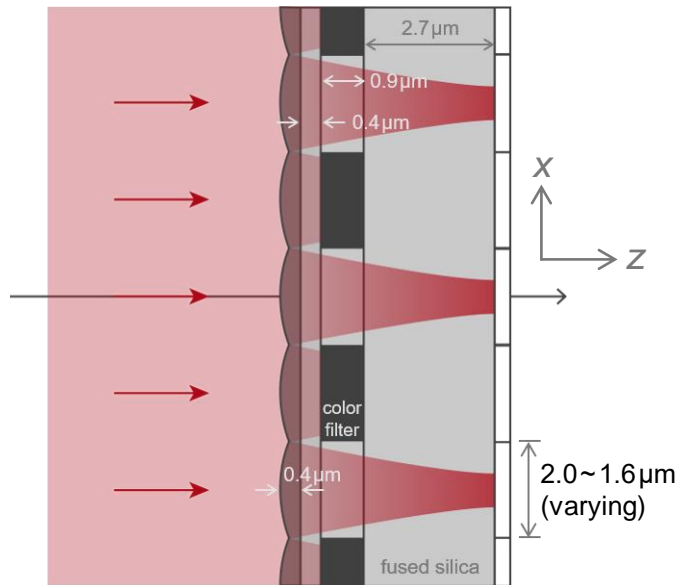
3D Simulation and Results Comparison



check the results on this plane



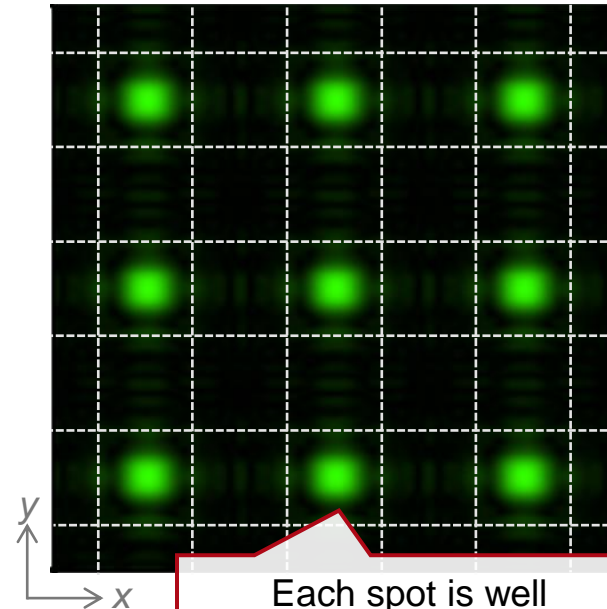
3D Simulation and Results Comparison



check the results on this plane

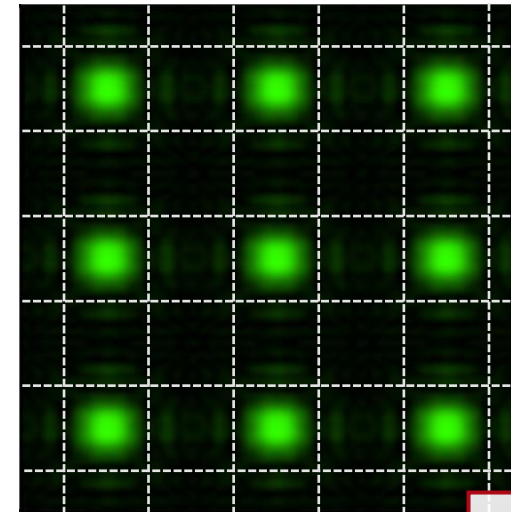
same scaling for all the result pictures

2 μm period

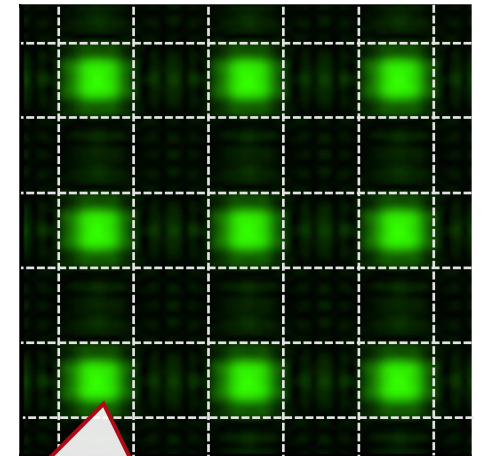


Each spot is well confined within the corresponding pixel area.

1.8 μm period



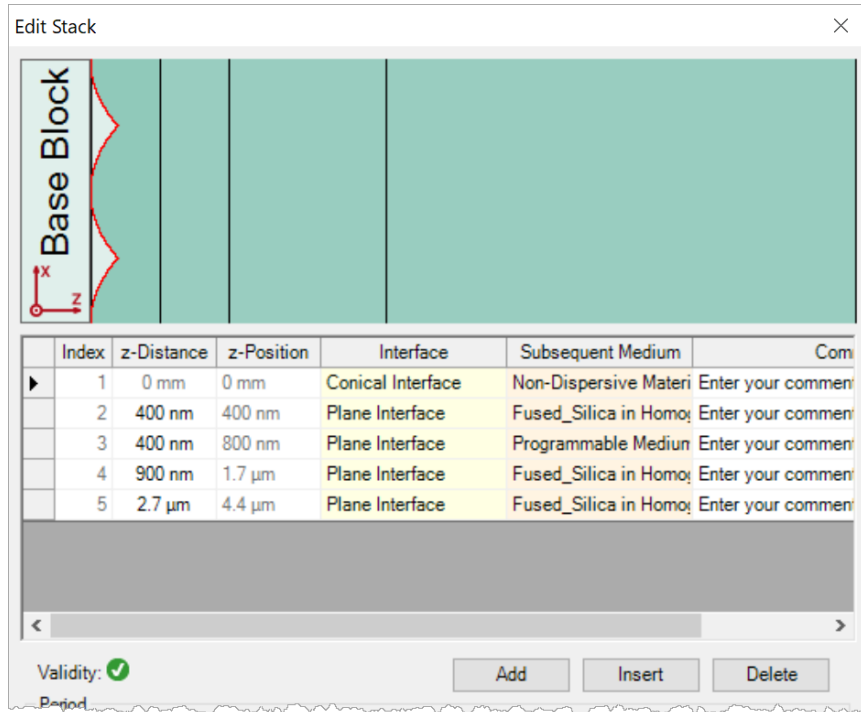
1.6 μm period



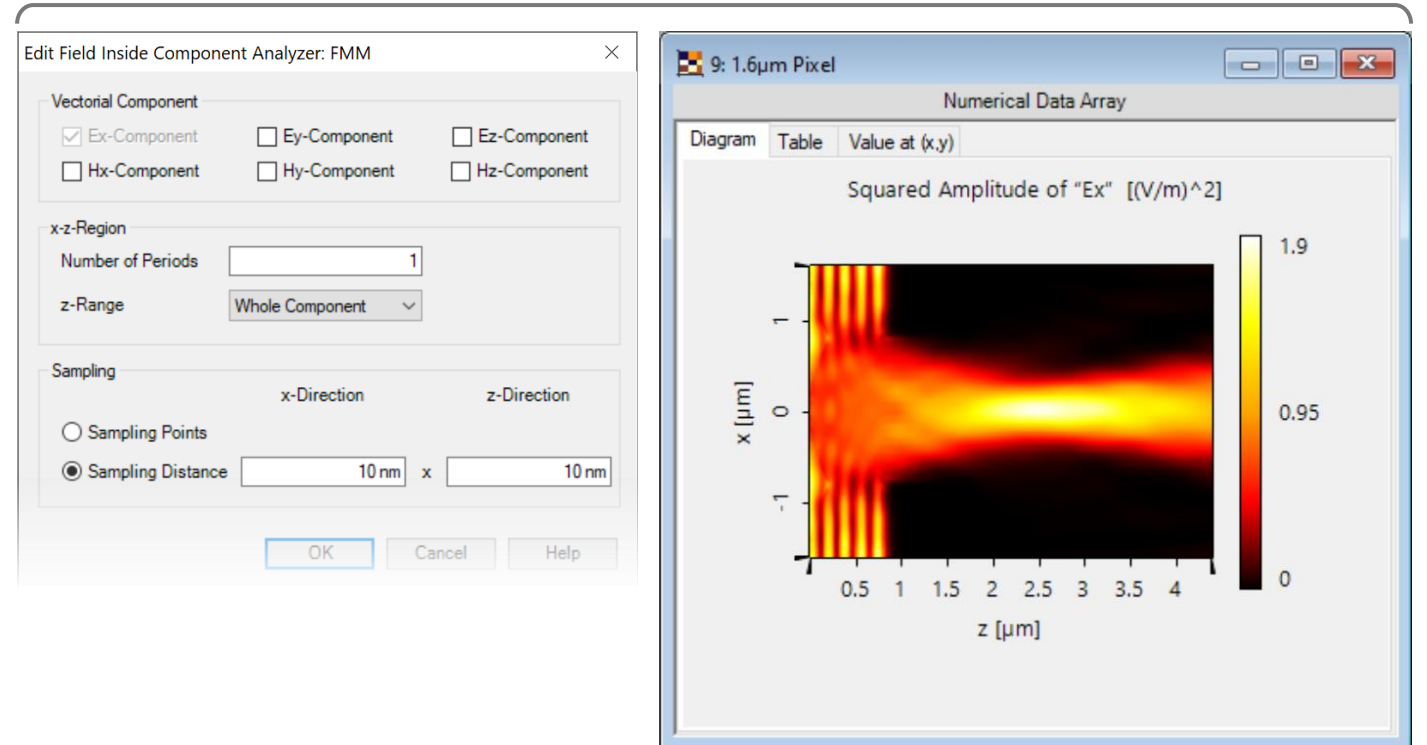
Light spots are barely confined, and crosstalk may happen for smaller pixels.

Peek into VirtualLab Fusion

flexible definition of micro-/nanostructures

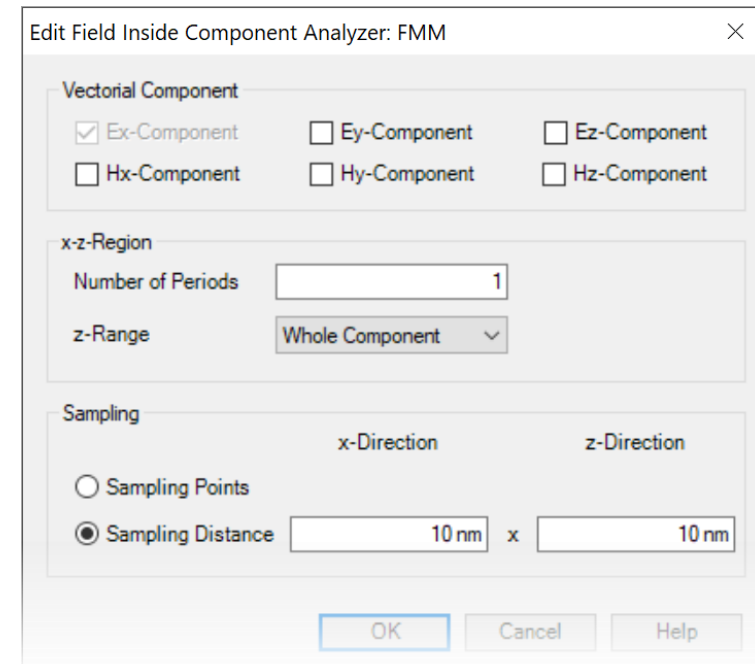


convenient setting and visualization of field inside structure

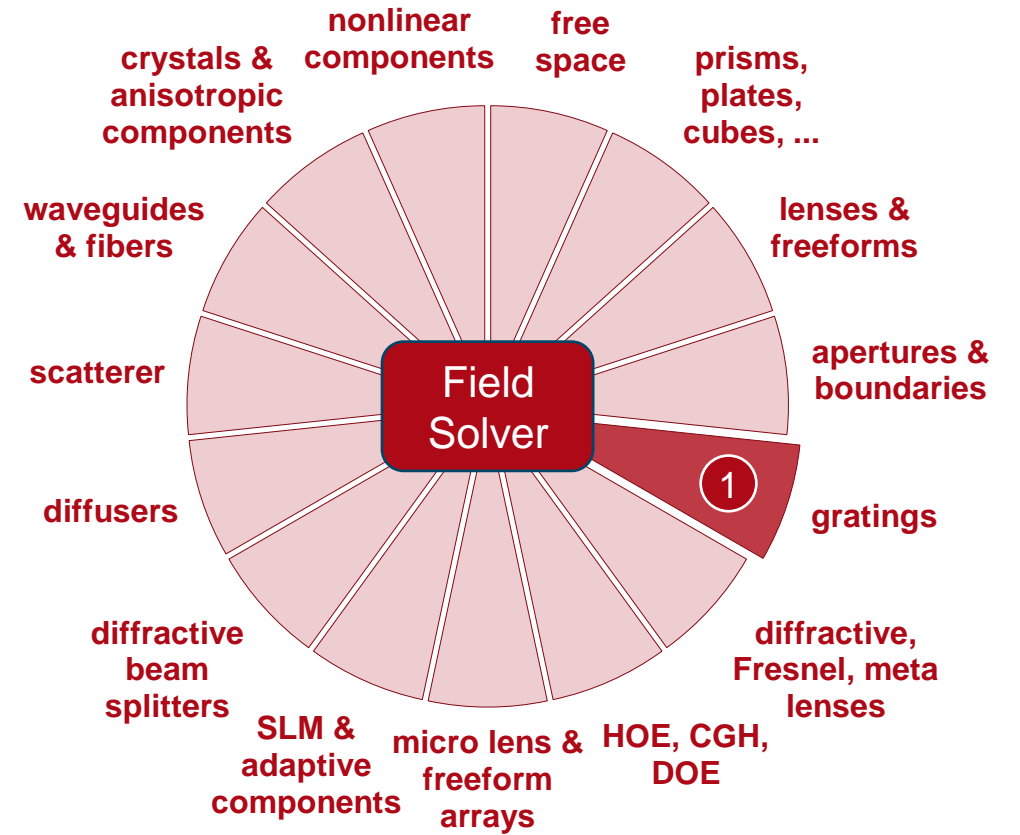
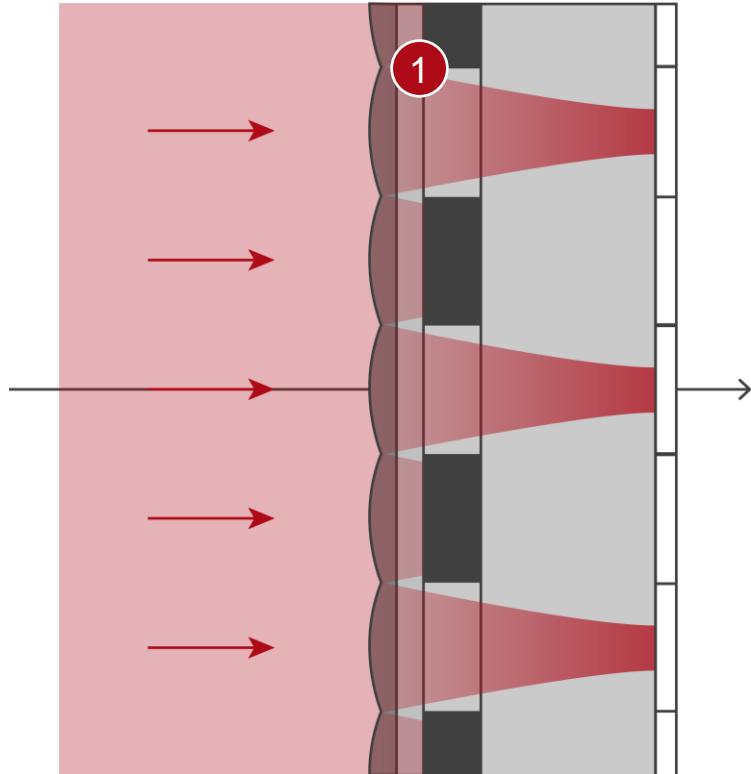


Workflow in VirtualLab Fusion

- Construct grating structure
 - [Configuration of Grating Structures by Using Interfaces](#) [Use Case]
 - [Configuration of Grating Structures by Using Special Media](#) [Use Case]
- Calculate field inside grating structure



VirtualLab Fusion Technologies



Document Information

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further reading	<ul style="list-style-type: none">- <u>Ultra-Sparse Dielectric Nano-Wire Grid Polarizers</u>- <u>Configuration of Grating Structures by Using Interfaces</u>- <u>Configuration of Grating Structures by Using Special Media</u>